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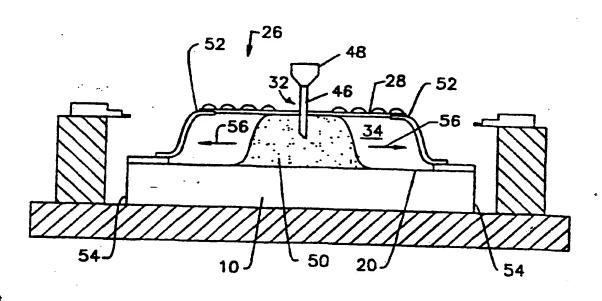
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(54) Title: METHOD OF FORMING INTERFACE BETWEEN DIE AND CHIP CARRIER



(57) Abstract

A method for creating an interface between a chip (10) and chip carrier (26) includes spacing the chip (10) a given distance above the chip carrier (26), and then introducing a liquid (50) in the gap (34) between the chip (10) and carrier (26). Preferably, the liquid (50) is an elastomer which is hardened into a resilient layer after its introduction into the gap (34). In another preferred embodiment, the terminals (331-34) on a chip carrier (326) are planarized or otherwise vertically positioned by deforming the terminals (331-34) into set vertical locations with a plate (380), and then hardening a liquid (350) between the chip carrier (326) and chip (310).

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DESCRIPTION

METHOD OF FORMING INTERFACE BETWEEN DIE AND CHIP CARRIER

Technical Field

The present invention relates to the field of semiconductor chip mounting and connection, and more particularly relates to methods of forming a mounting structure.

Background of the Invention

10 the construction of semiconductor chip assemblies. it has been found desirable to place elastomeric materials between some of the various components. For example, in some of the structur s disclosed in PCT/US91/06920 (filed September 24, 1991) by I. Khandros and T. Distefano, the disclosure of which 15 is incorporated herein by reference, a chip carrier includes a flexible dielectric layer with leads and an array of terminals. The chip carrier is fastened to a semiconductor chip or "die". An elastomeric material is disposed between the chip and the flexible dielectric 20 layer of the chip carrier. The chip carrier elastomeric material are also referred an "interposer". The leads of the chip carrier are bonded to the chip so that the terminals of the carrier are electrically connected to the contacts on the chip. 25 entire structure can then be mounted to a substrate such as a circuit panel or chip housing. The terminals of the chip carrier are electrically connected to contacts on the substrate. The elastomeric layer provides resiliency to the individual terminals, allowing each 30 terminal to move as necessary to accommodate tolerances during testing and in the final assembly itself.

In some arrangements used heretofore, the elastomeric layer was formed by casting a silicone rubber resin onto a release liner and curing. Next, additional resin was applied to each side of the cured sheet, the additional resin was partially cured, and the resulting tacky adhesive surface was used to bond the

elastomeric layer to the chip and chip carrier. attached, the entire structure was heated and fully

Although this process is effective, further 5 improvement would be desirable. The components are of small size and require instruments which are capable of handling such small components. occasionally entrapped when the chip carrier and die are can be affixed to the elastomer layer. The entrapped air can 10 create defects. Accordingly, care must be taken to prevent such entrapment. This adds to the expense of

Accordingly, further improvement desirable. Would be

15 Summary of the Invention

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The present invention addresses these needs. According to one embodiment of the present invention, a mounting a semiconductor chip includes placing a chip carrier a given distance above the chip to create a gap between the chip carrier and chip, and introducing a liquid into the gap, such that the liquid is disposed between the chip carrier and the chip.

Preferably, the liquid elastomer, and the method further includes hardening the 25 liquid after the liquid has been introduced into the gap, thereby forming a resilient layer in the gap. hardening step The includes transmitting radiant energy towards the liquid. curing liquid by 30

The liquid may be conveyed to the outer edges of the chip carrier, and the hardening step include hardening liquid exposed to the radiant energy at the outer edges of the chip carrier. Further, heat may be applied to thermally cure any liquid which was not cured 35 by the radiant energy.

Alternatively, the hardening step may include heating the liquid, such as by bringing the liquid to 100°C to 150°C, and preferably

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abou 120°C. On the other hand, the hardening step may include mixing a plurality of mutually reactive materials to form the liquid during or immediately before the introducing step such that the liquid cures by reaction of the materials. If desired, the liquid is heated after the mixing step.

Preferably, the introduction of liquid ceases when an amount of liquid sufficient to reach the edges of the chip carrier has been introduced. The method includes conveying the liquid to edges of the chip carrier after or during the step of introducing the liquid. The conveying step desirably includes forming a meniscus from the outer edges of the chip carrier to the outer edges of the chip, such that surface tension at the meniscus retains the liquid within the gap. The liquid desirably is conveyed to the outer edge of the chip carrier via surface wetting.

The method may also include introducing a predetermined amount of the liquid into the gap by pressurized injection. Further, the liquid may be prevented from passing beyond the outer edge of the chip carrier by disposing a mold immediately adjacent the outer edges of the chip carrier. Alternatively, the outer edges of the chip and chip carrier may be encapsulated by liquid by disposing the mold a spaced distance from the outer edges of the chip carrier, and allowing the liquid to fill the spaced distance.

The liquid may be introduced into the gap between the chip and the chip carrier via an aperture disposed at approximately the center of the chip carrier. A needle is inserted through the aperture to introduce the liquid into the gap.

In another aspect of the present invention, a method is provided for forming an elastomeric layer between a chip and a chip carrier. The chip carrier has edges, leads, and terminals in electrical connection with the leads. The method comprises placing the chip carrier a given distance above the chip to create a gap

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between the chip carrier and the chip, bonding the leads to the chip. A liquid elastomer into the gap, desirably after the bonding step has been completed, such that the liquid elastomer is disposed between the chip carrier and the chip, and the liquid elastomer is hardened after the liquid elastomer has been introduced into the gap.

Preferably, the leads are in contact with the liquid elastomer when the hardening step begins, and the leads are encased by the liquid elastomer when the hardening step begins.

Desirably, the chip carrier includes a support structure having a central portion and a peripheral portion, and the leads initially extend from the central portion of the support structure to the peripheral portion. The step of placing the chip carrier above the chip may include the step of supporting the peripheral portion of the support structure so that the central portion is supported above the chip by the leads. Further, the bonding step includes detaching the leads from the peripheral portion and connecting the leads to the chip. Preferably, this bonding step is performed serially, that the central portion such supported above the chip by connection of the leads to the peripheral portion, then by the connection of some of the leads to the chip and other of the leads to the lead frame, and finally by the connection of the leads to the chip.

The liquid may be partially cured initial curing step. 30 The terminals are then displaced to a preselected vertical location after the 'initial curing step, and finally the liquid is hardened. The displacing of the terminals involves pushing terminals downward with a plate. On the other hand, the terminals may be vertically located by placing a plate 35 adjacent the terminals before the introducing step, and the introduction of the liquid into the gap forces the terminals upward against the plate.

In yet another aspect of the present invention, a method is provided for positioning a plurality of terminals on one side of a flexible chip carrier layer. The method includes the step 5 disposing a layer of a flowable material such as a partially cured elastomeric material between the chip carrier layer and a chip such that the flowable layer is disposed beneath the flexible layer and the terminals extend upwardly from the flexible layer, away from the 10 flowable layer. Next, the terminals are pushed towards the chip with a molding plate until the tips of the terminals define a surface which substantially conforms to the shape of the molding plate. During this process, the flowable material flows to accommodate movement of the flexible layer. 15 Finally, the flowable layer is hardened after the pushing step, preferably while the terminals are defining the surface.

Preferably, the molding plate is planar, such that the surface defined by the terminals is planar.

The step of disposing the flexible layer may include placing the flexible layer a given distance above the chip to create a gap between the flexible layer and the chip, introducing a liquid elastomer into the gap, such that the liquid elastomer is disposed between the flexible layer and the chip, and partially curing the liquid elastomer to create a partially cured elastomeric layer. Alternatively, the partially cured but still flowable elastomeric layer may be applied first, and the chip carrier may be applied atop the partially cured layer.

Brief Description of the Drawings

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FIGURE 1 is a diagrammatic sectional view depicting components during one step of a process in accordance with one embodiment of the present invention.

FIGURE 2 is a diagrammatic top view depicting components during the same step of the process as seen in FIG. 1.

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FIGURE 3 is a diagrammatic sectional view depicting components during a later step of the process of FIGS 1-2.

FIGURE 4 is a diagrammatic sectional view depicting components during another later step of the process of FIGS. 1-3.

FIGURE 5 is a diagrammatic sectional view depicting components during yet another later step of the process of FIGS. 1-4.

FIGURE 6 is a diagrammatic sectional view depicting components during one step of a process in accordance with another embodiment of the present invention.

FIGURE 7 is a fragmentary diagrammatic sectional view depicting components during one step of a process in accordance with yet another embodiment of the present invention.

FIGURE 8 is a fragmentary diagrammatic sectional view depicting components during a later step of a process in accordance with said yet another embodiment of the present invention.

Best Mode of Carrying Out Invention

FIGURES 1 and 2 illustrate the initial stages of one process for forming an interface between a chip carrier and a chip. A chip or die 10 rests on the top side of a support structure 12. The support structure could be any relatively rigid surface, including a moving receptacle, conveyor belt, or the like.

For ease of reference, directions are stated in this disclosure with reference to the top side 20 of chip 10. Generally, directions referred to as "upward" or "rising from" shall refer to the direction orthogonal and away from the chip top surface 20. Directions referred to as "downward" shall refer to the directions orthogonal to the chip top surface 20 and opposite the upward direction. The term "above" a reference point shall refer to a point upward of the reference point, and the term "below" a reference point shall refer to a

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point downward of the reference point. The "top" of any individual element shall refer to the point or points of that element which extend furthest in the upward direction, and the term "bottom" of any element shall refer to the point or points of that element which extend furthest in the downward direction.

Disposed on the top side 20 of chip 10 are contacts 14. These contacts are of the type typically found on an integrated circuit chip.

Also disposed on the top surface 13 of support block 12 is lead frame support 16. Frame support 16 surrounds chip 10, and the top 18 of frame support 16 is higher than the top 20 of chip 10. Desirably, the top 18 of support 16 is about 0.12mm to about 0.22mm, and most preferably about 0.18mm higher than the top 20 of chip 10. Preferably, frame support 16 is a single open rectangular member which surrounds chip 10, the frame support having a left side 22 and a right side 24.

Held on the top 18 of frame support 16 is chip carrier 26. Chip carrier 26 includes structure or dielectric layer 28, leads 29, terminals 30. The dielectric layer or support structure 28 is a thin sheetlike flexible dielectric material, such as polyimide. Dielectric layer includes a central portion 27 and a peripheral portion 44, there being a slot 45 extending between central portion 27 and peripheral portion 44. portion 27 defines outer edges 52 bounding slots 45. Peripheral portion 44 overlies the top 18 of support 16. Peripheral portion 44 is clamped by suitable devices (not shown) on support 16. The peripheral portion may be formed as part of a continuous tape incorporating numerous chip carriers. On top of dielectric layer 28 are an array of terminals 30 which are made of an electrically conductive material such as soft gold of high purity.

The terminals 30 are electrically connected to fine wires or leads 29, which are attached to the bottom

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of the dielectric layer. The leads 29 extend beyond the outer edges of the central portion 27 of the dielectric layer and are releasably connected to the peripheral portion 44 of the layer. In the specific releasable connection shown, each lead has a frangible portion 36 outer edges of the dielectric central between the the connection with peripheral and 27 Any other form of releasable connection portion 44. between the lead and the peripheral portion can be employed. Leads with releasable connections including disclosed in are some frangible portions the forth U.S. Patent set in co-pending structures No. 07/919,772, filed July 24. Application (hereinafter "the '772 application"), the disclosure of incorporated herein by reference. structures including leads having releasable connections are disclosed in the co-pending commonly application of DiStefano, et al. entitled "Semiconductor Connection Components and Methods with Releasable Lead Support and Bus Structure", filed of even date herewith. The disclosure of this application is also incorporated herein by reference.

Thus, chip carrier 26 bridges across the left and right sides (22 and 24) of the frame support 16. The central portion 27 of the support structure or dielectric layer 28 is supported above the chip 10 by connection of the leads 29 to the peripheral section 44 of the dielectric layer overlying frame support 16. outer edges 52 of the chip carrier support structure central portion 27 extend generally parallel to the outer edges 54 of chip 10 but slightly inboard thereof. Because top 18 of lead support frame 16 is higher than the top 20 of chip 10, the chip carrier 26 will remain a given distance or height above chip 10, forming a The height of gap 34 is desirably between about 0.12mm to 0.22mm, and preferably about 0.18mm. Disposed at the center of chip carrier 26 is a small aperture 32 which communicates with gap 34. The WO 95/08856 PCT/US94/08812

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diameter of aperture 32 is desirably between about 0.25 mm and several millimeters, and preferably is about 3 mm.

After chip assembly is placed in its initial stages as shown in FIGURES 1 and 2, the leads 29 are 5 bonded to the contact pads 14 of chip 10, as shown in FIGURE 3. A tool 42, such as that disclosed in the '772 application mentioned above, grasps lead 29 at weakened portion 36. Tool 42 pushes lead 29 down, simultaneously holding end 40 of lead 29 as it breaks the lead at 10 weakened portion 36. Tool 42 moves end 40 towards contact pad 14, and eventually bonds the lead to the contact pad 14. Preferably, tool 42 bends lead 29 into an "S" shape by moving end 40 toward they central portion 27 of the support structure as end 40 is moved downward, rather than simply bending the lead toward the contact pad. An example of an "S"-shaped lead is disclosed in some of the structures set forth in the cocommonly assigned U.S. patent application entitled "Shaped Lead Structure and Method" of Kenneth Gilleo, et al. filed of even date herewith, disclosure of which is incorporated herein by reference.

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leads 29 are detached from peripheral portion 44 serially, such that no more than a few leads 29, and preferably only one lead, is or are being 25 separated from peripheral portion 44 at Therefore, the leads 29 will be gradually bonded to contact 14, rather than bonding all of the leads simultaneously. Because of this gradual connection, the central portion 27 the support of structure or dielectric layer 28 will maintain distance above chip 10. At any moment in time, the central portion 27 of the chip carrier dielectric layer will be supported by either the leads bonded to the contact pad 14 or by the leads which remain connected to the peripheral portion 44. In fact, the "S" shape of the connection of the leads to the contacts extremely effective in supporting chip carrier 26 above

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chip 10. Eventually, all the leads will be severed from peripheral portion 44, and central portion of chip carrier 26 will be entirely supported by the connection of leads 29 to contact pads 14.

FIGURE 4 illustrates the injection of a liquid into gap 34 after the leads have been bonded to chip 10. One end of a thin hollow needle 46 is inserted through aperture 32 into gap 34. Preferably, the needle is a 30 gauge. The other end of needle 46 is connected to a source of liquid, which is preferably a hardenable elastomer such as silicone rubber. In operation, source 48 applies enough pressure to cause liquid elastomer 50 enter gap region 34.

Next, the liquid elastomer is conveyed to the outer edges 52 of chip carrier central portion 27 and the outer edges 54 of chip 10. Although the present invention is not limited by any theory of operation, it is preferable for liquid to be conveyed to the outer edges by the capillary-like relationship of the liquid to the chip and chip carrier central portion. example, the surface tension of the liquid elastomer 50 should be low enough such that the liquid spreads along the surfaces of the chip and chip carrier upon its That is, the liquid should wet both the introduction. chip carrier and the chip. Such wetting of the surfaces facing gap 34 will cause the liquid to spread through the gap, away from aperture 32 and towards the outer edges of the chip and chip carrier. This movement is illustrated by flow directions 56 in FIGURE 4. the relative surface tensions, the angle of contact between the advancing edge of the liquid and the chip and chip carrier will be maintained as the liquid flows. It is further contemplated that due to the tendency of the liquid to wet the surfaces, the liquid will be "pulled" out of the needle 46, and little or no pressure at source 48 will be necessary to supply liquid to the However, some initial pressure will have to applied in order to bring some of the liquid out of the

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needle and into contact with the surfaces facing gap 34. Further, if the liquid is viscous, some pressure will aid filling the cavity more rapidly than if no pressure was applied.

5 As shown in FIGURE 5, the liquid will continue flowing along the top 20 of chip 10 and along the bottom of the dielectric layer 28 until it reaches the edges of the chip carrier and chip. Due to the surface tension in the advancing edge of liquid 50, the liquid will cease moving in directions 56 when it encounters a well-10 defined edge. Thus, the liquid elastomer 50 will completely fill gap 34, and stop at outer edge 54 of Additionally, the liquid will also tend to stop at the outer edge 52 of chip carrier central 15 portion 27.

The surface of the liquid will form a meniscus 59 between the outer edges 54 and 52 of the chip and chip carrier central portion. Surface tension will restrain the liquid 50 from proceeding beyond the boundaries of the chip or chip carrier. The liquid elastomer will also encapsulate leads 29 and contact pads 40 once the liquid elastomer 50 has reached the outer edges of the chip and chip carrier. Once the liquid reaches these edges, needle 46 will be withdrawn from gap 34.

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In essence, the introduction of liquid into gap 34 is self-regulating. The tendency of the liquid to wet the surfaces will end when the liquid reaches the edges of the chip and chip carrier. The cessation of wetting will prevent further liquid from being drawn from needle 46.

Once the liquid 50 has flowed to the edges of the chip and chip carrier, the liquid is cured in order to harden it into an elastomeric layer. For example, one method of curing would include polymerizing the liquid by applying thermal energy to the entire unit of chip carrier 26, elastomer 50 and chip 10. For example, with an elastomeric liquid elastomer composed of

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catalyzed silicone resin applying 140°C for ten minutes should sufficiently harden the elastomeric material. As defined in this disclosure, a "hardened" element should be understood to mean that an element which maintains its shape independent of the container. Accordingly, while the elastomer is "hardened", it will maintain resilient characteristics.

Once the elastomeric layer 50 has been cured, the assembly is complete. Chip carrier 26 will have a layer of elastomeric material 50 between it and the chip 10, providing terminals 30 with a sufficient degree resiliency. Such resiliency is particularly advantageous when the tops or tips of some terminals 30 are higher than the tips of other terminals. For example, if a test probe or substrate with ideally planar contacts is placed on a chip carrier terminals of varying heights, the resiliency of the elastomeric layer 50 will allow all of the terminals to come in contact with the corresponding probe's contacts, no matter what the height of the terminal. In other words, the higher terminals will be pushed downward until all of the terminals contact the probe's contacts.

This method of creating an elastomeric layer is especially advantageous in that it does not entrap any air between the elastomer and chip carrier or chip. In the present method, the outward flow of the liquid elastomer prevents the creation of air bubbles.

In addition, the liquid elastomer will conform to the shape and size of the chip 10 and chip carrier, no matter what that shape may be.

In addition to the preferred embodiment discussed above, the present invention allows for a great amount of variety in implementation. For example, rather than utilizing the principle of wetting, alternative methods may be used to fill the gap 34 and cause the liquid elastomer 50 to flow towards the outer edges of the chip carrier and chip. Specifically, a predetermined amount of liquid elastomer could be

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introduced into the gap by pressurized injection, thus pushing the liquid elastomer towards the outer edges of the chip and chip carrier in spite of the relative surface tensions of the components. Because meniscus 59 will stretch with the introduction of liquid into the gap, the meniscus provides a great deal of leeway in the amount of liquid which may be injected into the gap. pressurized injection is used, it is preferably to include some means preventing the for liquid from passing through the gap between the needle and the dielectric layer. For example, an annular rubber seal on the needle could close off the gap during injection.

Instead of relying upon the surface tension of the liquid to prevent the elastomer from passing beyond the edges of the assembly, a mold could be used to keep the liquid in place. For example, as shown in FIGURE 6, after the leads 229 have been severed from the peripheral portion of the dielectric layer (not shown), the peripheral portion and the support could be removed and replaced with a mold 260. The inside edges 259 of the mold 260 would directly abut the outer edges 254 of As the liquid elastomer is forced into the gap between chip carrier 226 and chip 210, the liquid elastomer 250 will reach the inner edges 259 of the mold 260. A meniscus would form between the outer edges of the chip carrier and the top of the mold to prevent the liquid from spilling over the mold. With the outer edges of the elastomer material 250 thus defined, the elastomer is cured with the mold in place, and then the mold 260 is removed. The elastomer, now in its cured and hardened state, would retain the shape it had while within the mold.

If desired, the outer edges of the chip and chip carrier could be encapsulated by the elastomer if the mold is placed a distance away from the outer edges of the components. Specifically, the liquid is forced to spill over the edges of the chip and chip carrier, and into the gap between chip carrier and mold.

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Afterwards, the liquid is hardened and the mold removed. The elastomer would thus encapsulate the sides of the assembly.

Various methods are also available to cure the liquid elastomer while it is within the gap between the chip carrier and the chip. For example, the elastomer may be a liquid elastomer which is curable by radiant energy such as ultraviolet light. The entire assembly of chip carrier, elastomer and chip can be irradiated with the radiant energy. The portions of the liquid elastomer which are exposed to the energy, i.e., the meniscus 59 (FIGURE 5), will cure and harden. portions of the liquid elastomer will be shielded from the energy by chip carrier 26 and chip 10, and will However, the uncured portion of the remain uncured. liquid will be encased by the hardened meniscus 59, chip carrier 26 and chip 10. Therefore, the uncured portion of elastomer 50 can be cured at a later time by other means, such as by heating the entire assembly.

The method of curing may be a function of the For example, if it composition of the liquid. desired to cure the elastomer in the presence of heat, two mutually-reactive materials may be premixed to form the liquid elastomer such that the entire composition cures over time, but much more rapidly in the presence of heat. On the other hand, the elastomer could be formed from highly-reactive materials mixed immediately These materials before its injection into the gap. would then quickly react in situ, hardening in place without the need of further curing methods. mixing, this combination of metering, dispensing is a form of low pressure reactive injection molding (RIM). If desirable, the assembly may be heated immediately after the elastomer reaches the edges of the chip carrier and chip, thus rapidly decreasing the total time required to cure the elastomer.

As discussed above, the resiliency of the elastomeric layer will allow vertical movement of the

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terminals to accommodate unequal terminal heights during testing and/or final assembly. In a further embodiment of the invention, the terminal heights may be equalized before testing or final assembly. Specifically, shown in FIGURE 7, terminals 331-334 may be of varying heights when affixed to dielectric layer 328 (the scales of FIGURES 7 and 8 are out of proportion for ease of reference). A liquid elastomer 350 is introduced in the gap between dielectric layer 328 and chip 310 in any of the methods discussed above. However, rather than immediately hardening the elastomer after its introduction between the dielectric layer 328 and chip 310, the material is only partially cured or "B-staged". This leaves the material in a quasiliquid state, such as In the gel or quasiliquid state, the material a gel. Will flow and undergo permanent deformation application of external force, but desirably will not flow under its own weight. Next, as shown in FIGURE 8, planar plate 380 pushes down on the terminals 331-334, causing the higher terminals such as 331 and 334 to be pushed towards chip 310 and into deformable flowable elastomer 350. Plate 380 will continue pushing downward until all of the terminals 331-334 are in contact with the plate. The elastomer 350 is then cured and hardened with plate 380 maintaining its contacts with the terminals. At this point, the plate 380 can be removed, and the of the terminals 331-334 will maintain their position due to the now hardened elastomer 350. Accordingly, the tips of the terminals planarized, but still capable of resilient motion towards and away from the elastomeric layer. Of course, instead of pushing plate 380 downwards, it is also possible to push the entire assembly upwards towards a stationary plate.

If a non-planar terminal height is preferred, a plate of any non-planar shape could be used to set the heights of the terminals. In other words, rather than

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being "planarized", the tips of the terminals can be more generally "verticalized" to define nearly any shaped surface area. If it is desirable for the terminals closer to the outer edges of the chip carrier to be higher than the terminals closer to the center of the chip carrier, a convex plate could be used to vertically locate the outer terminals higher than the inner terminals.

Instead of pushing the terminals down while a partially cured elastomer 350 is in place, it is also contact with possible to bring plate in 380 liquid is introduced. the before terminals Specifically, the plate 380 is first brought in contact the highest terminals and 334. 331 pressurized liquid is introduced into the gap, and the pressure of the liquid is used to push the dielectric shorter terminals towards up the and cease moving The terminals will stationary plate. towards the plate when they reach the plate's surface. The liquid is cured with the plate in place, and when the plate is removed, the vertical location of the terminals will retain the shape of the plate.

Also, rather than introducing the liquid under pressure and bringing the plate downwards, contemplated that the surface tension of the liquid alone may be sufficient to planarize the terminals dielectric layer If the against the plate. sufficiently flexible, the surface tension of the liquid will tend to deform the liquid and dielectric layer into a hemispherical shape, absent outside forces. Bv placing the plate immediately above the chip carrier and then introducing the liquid, the liquid will still tend to bulge hemispherically, but is stopped by the presence of the plate immediately above the chip carrier (see Accordingly, the tendency of the liquid FIGURE 8). towards a hemispherical shape will push the chip carrier against the flat adjacent plate, thus planarizing the terminals.

The introduction of a liquid into the gap is not required in order to planarize the terminals in accordance with the present invention. For example, a preformed sheet of partially cured elastomer may be placed between the chip and chip carrier, the terminals then vertically located with a molding plate, finally the partially cured elastomer sheet is hardened or B-staged. While this method does not have the unique advantages forming of elastomeric an layer introducing a liquid in between the chip and chip carrier, it does retain the advantages of planarizing terminals in accordance with the present invention.

Although the invention herein has described with reference to particular embodiments, it is to be understood that the embodiments are merely illustrative of the principles and application of the present invention. It is therefore to be understood that numerous modifications may be made embodiments and that other arrangements may be devised without departing from the spirit and scope of the present invention as defined by the claims.

Industrial Applicability

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Useful for making electronic assemblies such as semiconductor chip assemblies.

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WHAT IS CLAIMED IS:

1. A method of forming a mounting structure for a semiconductor chip (10) characterized by the steps of

placing a chip carrier (26) a given distance above said chip (10) to create a gap (34) between said chip carrier (26) and said chip (10),

introducing a liquid (50) into said gap (34), such that said liquid (50) is disposed between said chip carrier (26) and said chip (10).

- 2. The method of claim 1 characterized in that said liquid (50) is a hardenable elastomer.
- 3. The method of claim 2 further characterized by the step of hardening said liquid (50) after said liquid has been introduced into said gap (34) to thereby form a resilient layer in said gap (34).
- 4. The method of claim 3 characterized in that said hardening step includes curing said liquid (50) by transmitting radiant energy towards said liquid (50).
- 5. The method of claim 4 characterized in that said introducing step includes the step of conveying said liquid (50) to the outer edges (52) of said chip carrier (26), and characterized in that said hardening step includes the step of hardening liquid (50) exposed to said radiant energy at the outer edges (52) of said chip carrier.
- 6. The method of claim 5 further characterized by the step of applying heat to thermally cure any liquid (50) which was not cured by said radiant energy.
- 7. The method of claim 3 characterized in that said hardening step includes heating said liquid (50).
- 35 8. The method of claim 7 characterized in that said heating step includes the step of bringing said liquid (50) to between about 100°C to 150°C.

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- 9. The method of claim 3 characterized in that said hardening step comprises mixing a plurality of mutually reactive materials to form said liquid (50) during or immediately before said introducing step such that said liquid (50) cures by reaction of said materials.
- 10. The method of claim 9 characterized in that said liquid (50) is heated after said mixing step.
- 11. The method of claim 3 further characterized by the step of ceasing said introducing step when an amount of liquid (50) sufficient to reach outer edges (52) of said chip carrier (26) has been introduced.
- 12. The method of claim 3 further characterized by the step of conveying said liquid (50) to said outer edges (52) of said chip carrier (26) after or during said introducing step.
- 13. The method of claim 12 characterized in that said conveying step includes said liquid (50)

 20 forming a meniscus (59) from said outer edges (52) of said chip carrier (26) to said outer edges (54) of said chip (10), such that said meniscus (59) retains said liquid (50) within said gap.
- 14. The method of claim 13 characterized in that said conveying step includes conveying said liquid (50) to said outer edges (52) of said chip carrier (26) via surface wetting.
- 15. The method of claim 12 characterized in that said introducing step includes introducing a predetermined amount of liquid (50) into said gap (34) by pressurized injection.
 - 16. The method of claim 12 further characterized by preventing said liquid (50) from passing beyond said outer edges (52) of said chip carrier (26) by disposing a mold immediately adjacent said outer edges (52) of said chip carrier (26).
 - 17. The method of claim 12 further characterized by encapsulating said outer edges (252) of

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said chip carrier (226) and chip (210) by disposing a mold (260) a spaced distance from said outer edges (252) of said chip carrier (226) and introducing said liquid (250) into said spaced distance.

- 18. The method of claim 3 characterized in that said introducing step includes introducing said liquid (50) into said gap (34) via an aperture (32) disposed at approximately the center of the chip carrier (26) as defined by said outer edges (52) of said chip carrier (26).
- 19. The method of claim 18 characterized in that said introducing step includes inserting a needle (46) through said aperture (32) to introduce said liquid (50) into said gap (34).
- 20. The method of claim 3 characterized in that said given distance of said gap (34) is between about 5 to 9 mils.
 - 21. The method of claim 20 characterized in that said given distance of said gap (34) is about 7 mil.
 - 22. A method of forming an elastomeric layer between a chip (10) and a chip carrier (26) having leads (29), and terminals (30) in electrical connection with said leads (29), said method characterized by the steps of placing said chip carrier (26) a given distance above said chip (10) to create a gap (34) between said chip carrier (26) and said chip (10),

bonding said leads (29) to said chip (10),

introducing a liquid elastomer (50) into said gap (34), such that said liquid elastomer (50) is disposed between said chip carrier (26) and said chip (10), and

hardening said liquid elastomer (50) after said liquid elastomer (50) has been introduced into said gap (34).

23. The method of claim 22 characterized in that said leads (29) are in contact with said liquid elastomer (50) when said hardening step begins.

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- 24. The method of claim 23 characterized in that said leads (29) are encased by said liquid elastomer (50) when said hardening step begins.
- that said chip carrier (26) includes a support structure having a central portion (27) bearing said terminals (30) and a peripheral portion (44), said leads (29) initially extending from said central portion (27) to said peripheral portion (44), said placing step characterized by the step of supporting said peripheral portion (44) so that said central portion (27) of said support structure lies above said chip (10), said bonding step including the step of detaching said leads (29) from said peripheral portion (44) and connecting said leads (29) to said chip (10).
- 26. The method of claim 25 characterized in that said bonding step includes detaching said leads (29) serially, such that said central portion (27) of said support structure is first supported above said chip (10) by connection of said leads (29) to said peripheral portion (44), then by the connection of some of said leads (29) to said chip (10) and some of the other leads (29) to said peripheral portion (44), and finally by the connection of said leads (29) to said
 - 27. The method of claim 22 characterized in that said hardening step includes the steps of partially curing said liquid (350) in an initial curing step and then finally hardening said partially cured liquid (350),

the method further characterized by the step of displacing said terminals (331-34) to a preselected vertical location after said initial curing step and before said hardening step.

28. The method of claim 27 characterized in that said displacing step comprises pushing said terminals (331-34) downward with a plate (380).

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- 29. The method of claim 22 further characterized by the step of controlling said vertical location of said terminals (331-34) by placing a plate (380) adjacent said terminals before said introducing step, such that the introduction of said liquid (350) within said gap (34) forces said terminals (331-34) upward against said plate (380).
- 30. A method of positioning a plurality of terminals (331-333) on one side of a flexible chip carrier layer (328), said method characterized by the steps of

disposing a partially cured layer of flowable material (350) between said chip carrier layer (328) and a chip (310) such that said layer of flowable material (350) is disposed beneath said flexible layer (328) and said terminals (331-34) extend upwardly from said flexible layer (328) away from said layer (328) of flowable material (350),

pushing said terminals (331-34) towards said chip (310) with a molding plate (380) until the tips of said terminals (331-34) define a surface which substantially conforms to the shape of said molding plate (380),

hardening said layer of flowable material (350) after said pushing step while said terminals (331-34) are defining said surface.

- 31. A method as claimed in claim 30 characterized in that said flowable material (350) forms an elastomer during said hardening step.
- 32. A method as claimed in claim 31 characterized in that said flowable material (350) is partially cured but remains flowable prior to said pushing step.
- 33. The method of claim 30 characterized in that said molding plate is planar (380), whereby said surface defined by said terminals (331-34) will be planar.

34. The method of claim 33 characterized in that said disposing step comprises placing said flexible layer (328) a given distance above said chip (310) to create a gap (34) between said flexible layer (328) and said chip (310),

introducing a liquid elastomer (350) into said gap (34), such that said liquid elastomer (350) is disposed between said flexible layer (328) and said chip (310), and

partially curing said liquid elastomer (350) to create a partially cured but flowable elastomeric layer (350).

AMENDED CLAIMS

[received by the International Bureau on 05 January 1995(05.01.95); original claims 1,3,11 and 22 amended; remaining claims unchanged (6 pages)]

- 1. A method of forming a mounting structure for a semi-conductor chip (10) characterized by th steps of
- providing a flexible chip carrier (26) having a top surface and a bottom surface, terminals (30) disposed on said top surface and leads (29) in electrical connection with said terminals,
- placing said chip carrier (26) a given

 10 distance above said chip (10) to create a gap (34)

 between said chip carrier (26) and said chip (10), said

 bottom surface facing said chip;

bonding said leads to said chip; and introducing a liquid (50) into said gap (34), such that said liquid is disposed between said chip carrier (26) and said chip (10).

- 2. The method of claim 1 characterized in that said liquid (50) is a hardenable elastomer.
- 3. The method of claim 2 further characterized by the step of hardening said liquid (50) after said liquid has been introduced into said gap (34) to thereby form a resilient layer in said gap (34) such that said terminals (30) may be flexibly displaced towards and away from said chip.
- 4. The method of claim 3 characterized in that said hardening step includes curing said liquid (50) by transmitting radiant energy towards said liquid (50).
- The method of claim 4 characterized in 5. 30 that introducing step said includes the step of conveying said liquid (50) to the outer edges (52) of said chip carrier (26), and characterized in that said hardening step includes the step of hardening liquid (50) exposed to said radiant energy at the outer edges 35 (52) of said chip carrier.
 - 6. The method of claim 5 further characterized by the step of applying heat to thermally

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cure any liquid (50) which was not cured by said radiant

- The method of claim 3 characterized in 7. that said hardening step includes heating said liquid
- The method of claim 7 characterized in 8. that said heating step includes the step of bringing said liquid (50) to between about 100°C to 150°C.
- The method of claim 3 characterized in that said hardening step comprises mixing a plurality of 10 mutually reactive materials to form said liquid (50) during or immediately before said introducing step such liquid (50) cures by reaction of materials.
- 15 The method of claim 9 characterized in 10. that said liquid (50) is heated after said mixing step.
 - The method of claim characterized by the step of ceasing said introducing step when an amount of liquid (50) sufficient to reach said outer edges (52) of said chip carrier (26) has been
 - 12. The method of claim characterized by the step of conveying said liquid (50) further to said outer edges (52) of said chip carrier (26) after or during said introducing step. 13.
- The method of claim 12 characterized in that said conveying step includes said liquid (50) forming a meniscus (59) from said outer edges (52) of said chip carrier (26) to said outer edges (54) of said chip (10), such that said meniscus (59) retains said 30 liquid (50) within said gap.
 - The method of claim 13 characterized in that said conveying step includes conveying said liquid (50) to said outer edges (52) of said chip carrier (26) via surface wetting.
 - The method of claim 12 characterized in that introducing step said includes introducing a

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predetermined amount of liquid (50) into said gap (34) by pressurized injection.

- 16. The method of claim 12 further characterized by preventing said liquid (50)from passing beyond said outer edges (52) of said chip carrier (26) by disposing a mold immediately adjacent said outer edges (52) of said chip carrier (26).
- 17. The method of claim 12 characterized by encapsulating said outer edges (252) of said chip carrier (226) and chip (210) by disposing a mold (260) a spaced distance from said outer edges (252) of said chip carrier (226) and introducing said liquid (250) into said spaced distance.
- The method of claim 3 characterized in that said introducing step includes introducing said 15 liquid (50) into said gap (34) via an aperture (32) disposed at approximately the center of the chip carrier (26) as defined by said outer edges (52) of said chip carrier (26).
- The method of claim 18 characterized in 20 19. that said introducing step includes inserting a needle (46) through said aperture (32) to introduce said liquid (50) into said gap (34).
- The method of claim 3 characterized in 20. that said given distance of said gap (34) is between 25 about 5 to 9 mils.
 - The method of claim 20 characterized in 21. that said given distance of said gap (34) is about 7 mil.
- 22. A method of forming an elastomeric layer 30 between a chip (10) and a chip carrier (26) having a top and bottom surface, terminals (30) disposed on said top surface; and leads (29) in electrical connection with leads (29), said method characterized by the steps of
- 35 placing said chip carrier (26) a given distance above said chip (10) to create a gap (34)

between said chip carrier (26) and said chip (10), said bottom surface of said chip carrier facing said chip,

bonding said leads (29) to said chip (10), introducing a liquid elastomer (50) into said gap (34), such that said liquid elastomer (50) is disposed between said chip carrier (26) and said chip (10), and

hardening said liquid elastomer (50) after said liquid elastomer (50) has been introduced into said gap (34).

- 23. The method of claim 22 characterized in that said leads (29) are in contact with said liquid elastomer (50) when said hardening step begins.
- 24. The method of claim 23 characterized in that said leads (29) are encased by said liquid elastomer (50) when said hardening step begins.
- The method of claim 22 characterized in 25. that said chip carrier (26) includes a support structure having a central portion (27) bearing said terminals (30) and a peripheral portion (44), said leads (29) initially extending from said central portion (27) to 20 peripheral portion (44), said placing characterized by the step of supporting said peripheral portion (44) so that said central portion (27) of said support structure lies above said chip (10), said bonding step including the step of detaching said leads 25 (29) from said peripheral portion (44) and connecting said leads (29) to said chip (10).
- that said bonding step includes detaching said leads

 (29) serially, such that said central portion (27) of
 said support structure is first supported above said
 chip (10) by connection of said leads (29) to said
 peripheral portion (44), then by the connection of same
 of said leads (29) to said chip (10) and some of the
 other leads (29) to said peripheral portion (44), and
 finally by the connection of said leads (29) to said
 chip (10).

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27. The method of claim 22 characterized in that said hardening step includes the steps of partially curing said liquid (350) in an initial curing step and then finally hardening said partially cured liquid (350),

the method further characterized by the step of displacing said terminals (331-34) to a preselected vertical location after said initial curing step and before said hardening step.

- 28. The method of claim 27 characterized in that said displacing step comprises pushing said terminals (331-34) downward with a plate (380).
 - 29. The method of claim 22 further characterized by the step of controlling said vertical location of said terminals (331-34) by placing a plate (380) adjacent said terminals before said introducing step, such that the introduction of said liquid (350) within said gap (34) forces said terminals (331-34) upward against said plate (380).
- 30. A method of positioning a plurality of terminals (331-333) on one side of a flexible chip carrier layer (328), said method characterized by the steps of
- disposing a partially cured layer of flowable
 material (350) between said chip carrier layer (328) and
 a chip (310) such that said layer of flowable material
 (350) is disposed beneath said flexible layer (328) and
 said terminals (331-34) extend upwardly from said
 flexible layer (328) away from said layer (328) of
 flowable material (350),

pushing said terminals (331-34) towards said chip (310) with a molding plate (380) until the tips of said terminals (331-34) define a surface which substantially conforms to the shape of said molding plate (380),

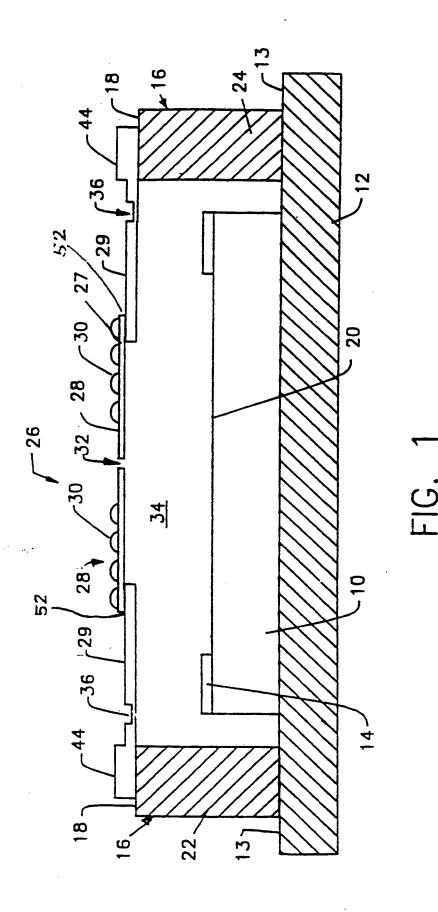
hardening said layer of flowable material (350) after said pushing step while said terminals (331-34) are defining said surface.

- 31. A method as claimed in claim 30 characterized in that said flowable material (350) forms an elastomer during said hardening step.
 - 32. A method as claimed in claim 31 characterized in that said flowable material (350) is partially cured but remains flowable prior to said pushing step.
 - 33. The method of claim 30 characterized in that said molding plate is planar (380), whereby said surface defined by said terminals (331-34) will be planar.
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 34. The method of claim 33 characterized in that said disposing step comprises placing said flexible layer (328) a given distance above said chip (310) to create a gap (34) between said flexible layer (328) and said chip (310),

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- introducing a liquid elastomer (350) into said gap (34), such that said liquid elastomer (350) is disposed between said flexible layer (328) and said chip (310), and
- partially curing said liquid elastomer (350) to create a partially cured but flowable elastomeric layer (350).



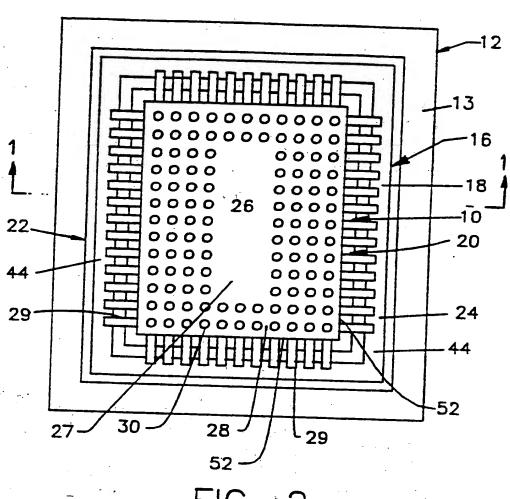
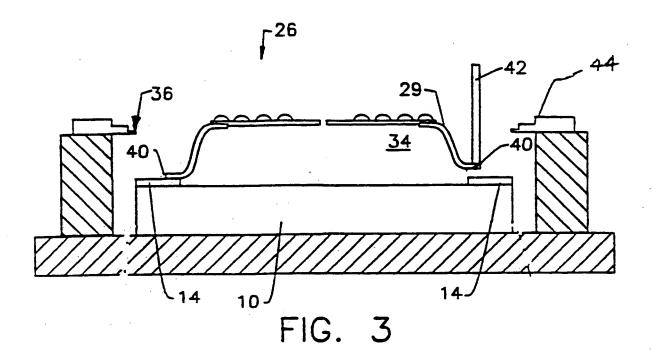
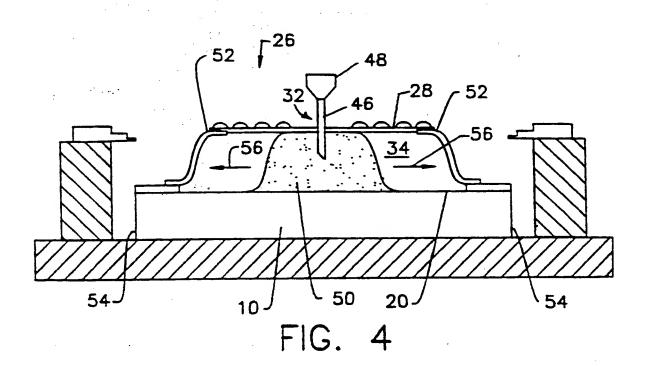
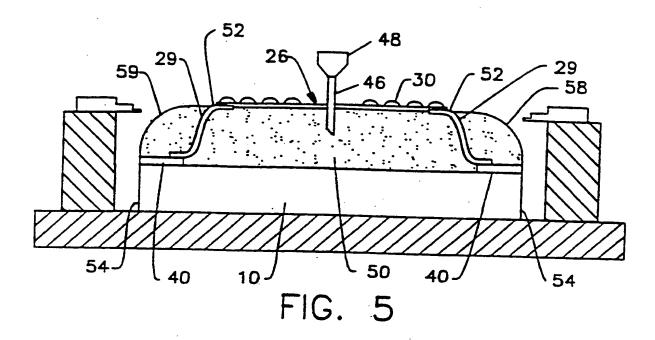
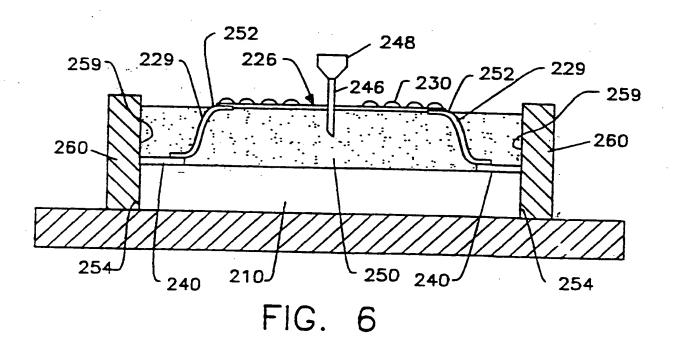


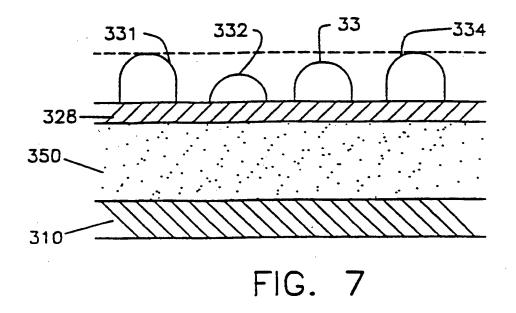
FIG. 2











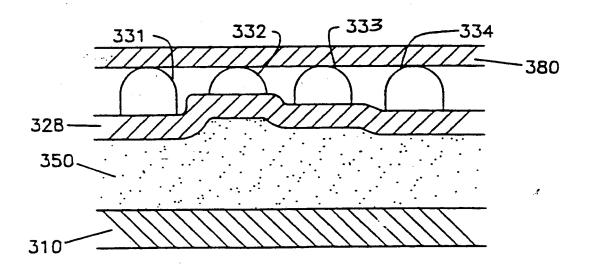


FIG. 8

INTERNATIONAL SEARCH REPORT

International application No. PCT/US94/08812

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A. (LASSIFICATION OF SUBJECT MATTER	
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	documentation searched (classification system followed by classification symbol	
U.S. :	174/52.2/52.4; 427/96; 437/207, 211, 219; 257/667, 676, 787	
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INTERNATIONAL SEARCH REPORT

International application No. PCT/US94/08812

Category*	Citation of document, with indication, where appropriate, of the relevant passages	2.
	Type of the following passages	Relevant to claim N
X	US, A, 4,857,483 (STEFFEN ET AL) 15 AUGUST 1989 SEE ENTIRE DOCUMENT	1
X Y	US, A, 4,897,534 (HAGHIRI-TEHRANI) 30 JANUARY 1990 SEE ENTIRE DOCUMENT	1
X	US, A, 5,055,913 (HAGHIRI-TEHRANI) 08 OCTOBER 1991 SEE ENTIRE DOCUMENT	2,3,7,8,18
Y		2,3,7,8,18
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